IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

267

In re the Application of

Saxoshi INOUE et al.

acation No.: 09/899,058

d: July 6, 2001

SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE

Docket No.: 11

1.

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

JUN 2 7 2002

Technology Center 2600

Sir:

For:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

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JAO:TJP/al

Date: June 26, 2002

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

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DIFORMATION DISCLOSURE STATEMENT									
(Use several sheets if necessary)			APPLICANTS						
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Date: June 26, 2002